

03/30/2005

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Sheet 1 of 1		INFORMATION DISCLOSURE STATEMENT					
FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary) Date Submitted to PTO: March 30, 2005			ATTY DOCKET NO. 2005-0526A		SERIAL NO. NEW 10/529760		
			APPLICANT Daisuke FUJITA				
			FILING DATE March 30, 2005		GROUP 2818		
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
PD	AA	6,608,306	8/2003	Aono et al.	—	—	
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
PD	AJ	00/70325	11/2000	WO	—	—	ABSTRACT
PD	AK	07-065705	3/1995	Japan	—	—	ABSTRACT
	AL						
	AM						
	AN						
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
PD	AO	C.S. Chang et al., "Field Evaporation between a Gold Tip and a Gold Surface in the Scanning Tunneling Microscope Configuration", Physical Review Letters, Vol. 72, No. 4, pages 574-577, January 24, 1994.					
PD	AP	D.M. Kolb, "Nanoscale decoration of electrode surface with an STM", Solid State Ionics, Vol. 131, pages 69-78, June 1, 2000.					
PD	AQ	D. Fujita and T. Kumakura, "Reproducible fabrication of metallic silver nanostructures on a Si (111)-(7x7) surface by tip-material transfer of a scanning tunneling microscope", Applied Physics Letters, Vol. 82, No. 14, pages 2329-2331, April 7, 2003.					
EXAMINER PHUC T. DANG				DATE CONSIDERED 2/28/2007			

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of form with next communication to applicant.